

PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Scott J. DeBoer et al.

Serial No.: 10/786,348

Filed: February 24, 2004

For: **DOUBLE SIDED CONTAINER PROCESS  
USED DURING THE MANUFACTURE  
OF A SEMICONDUCTOR DEVICE**

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§ GAU: 2814

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§ Examiner: Hoai V. Pham

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§ Docket No: 1999-1335.01/US

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§ Confirmation No.: 4548

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*Antecedent/RCE  
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2/6/04*  
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P.O. Box 1450  
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Signature

**RESPONSE TO THE FINAL OFFICE ACTION OF MAY 25, 2005**

Please enter the following in response to the final office action mailed May 25, 2005 as paper no. 05232005.

Micron Technology, Inc.

1999-1335.01/US